



Serial No. 10/071,099

SEC.936

Amendment dated 21 June 2004

AF/2872  
IFW

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of:

Jai Young WOO et al.

Group Art Unit: 2872

Serial No.: 10/071,099

Examiner: Thong Q. NGUYEN

Filed: 11 February 2002

**MICROSCOPE FOR INSPECTING  
SEMICONDUCTOR WAFER**

**AMENDMENT UNDER 37 C.F.R. § 1.116**

U.S. Patent and Trademark Office  
2011 South Clark Place  
Customer Window, Mail Stop AF  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Sir:

In response to the Office Action dated 29 March 2004, the period for response to which extends through 29 June 2004, please amend the above-identified patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.